

Docket No.: HSI-0001

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Sang Dae KIM et al.

Serial No: 10/621,471

Filed: July 18, 2003

Confirmation No.: 1151

Group Art Unit: 1763

Examiner: Richard R. BUEKER

Customer No.: 34610



For: SOURCE FOR THERMAL PHYSICAL VAPOR DEPOSITION OF ORGANIC ELECTROLUMINESCENT LAYERS

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, Virginia 22314

Dear Sir:

Transmitted herewith is an Amendment and/or Reply in the above identified application.

- ☐ No additional fee is required.
☒ Also attached: Request for Correction of Inventorship

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	12	23	0	x \$50.00 =	\$0.00
Independent Claims	4	4	0	x \$200.00 =	\$0.00
Request Fee					\$130.00
Fee for extension of time					\$0.00
TOTAL FEE DUE					\$130.00

- ☐ Please charge my Deposit Account No. 16-0607 in the amount of \$____. An additional copy of this transmittal sheet is submitted herewith.
- ☒ A check in the amount of \$130.00 (Check # 11039) is attached.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 16-0607, including any filing fees under 37 C.F.R. 1.16 for presentation of extra claims and any patent application processing fees under 37 C.F.R. 1.17.

Respectfully submitted,
FLESHNER & KIM, LLP

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Date: October 27, 2005

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